Docket No. AM2420D02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Application of

Haruhiro H. Goto

Serial No.:

Examiner:

Filed: Herewith

Group Art Unit:

For: SYSTEM AND METHOD FOR GAS

DISTRIBUTION IN A Dry Etch

PRELIMINARY AMENDMENT

To: Assistant Commissioner for Patents

Washington, DC 20231

Sir:

Please enter the following amendments to the claims.